

## Supporting Information

### Rapid Synthesis of Vertically Aligned $\alpha$ -MoO<sub>3</sub> Nanostructures on Substrates

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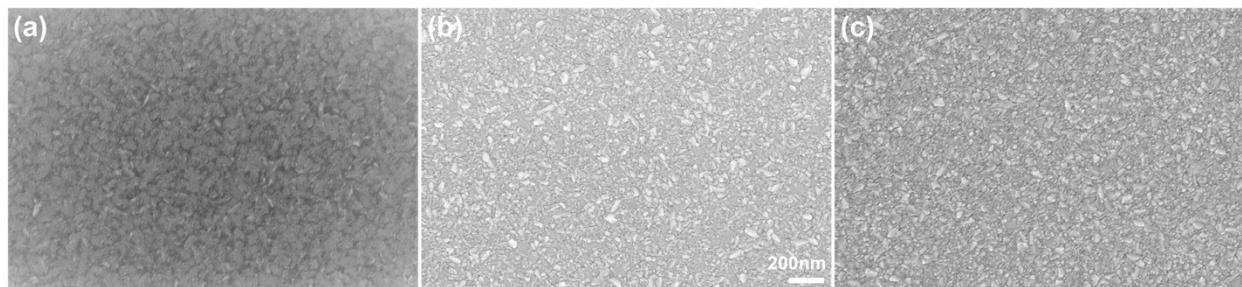
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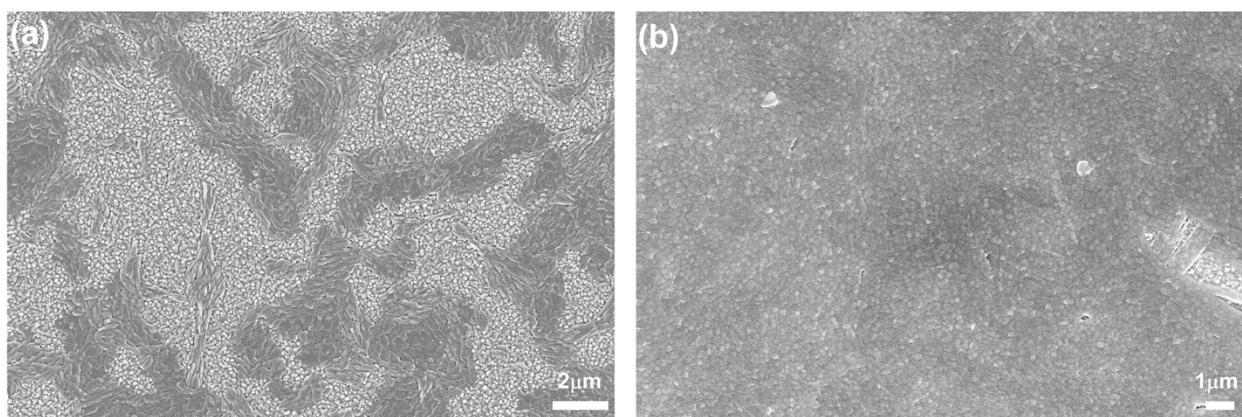
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**Table 1.** Lattice parameters of the substrates and the adhesive formed layer of Cr oxides for the calculation of the lattice mismatch.

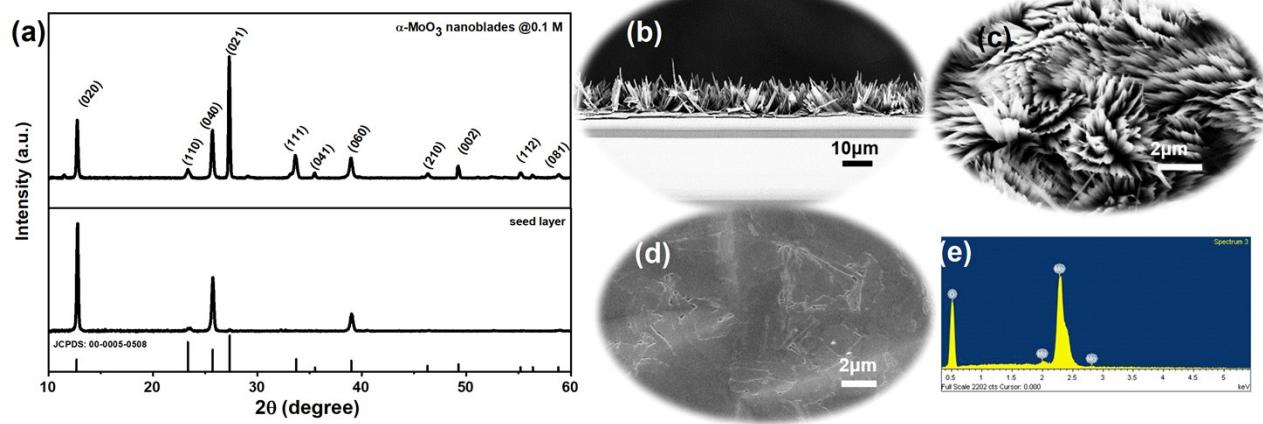
Material	a (Å)	b (Å)	c (Å)	Ref. Card
FTO (substrate)	4.737	4.737	3.186	00-77-0447
SiO <sub>2</sub> (substrate)	5.082	5.082	7.095	01-086-1561
Cr <sub>2</sub> O <sub>3</sub>	4.958	4.958	13.593	00-006-0504
Cr <sub>3</sub> O	4.544	4.544	4.544	01-072-0528



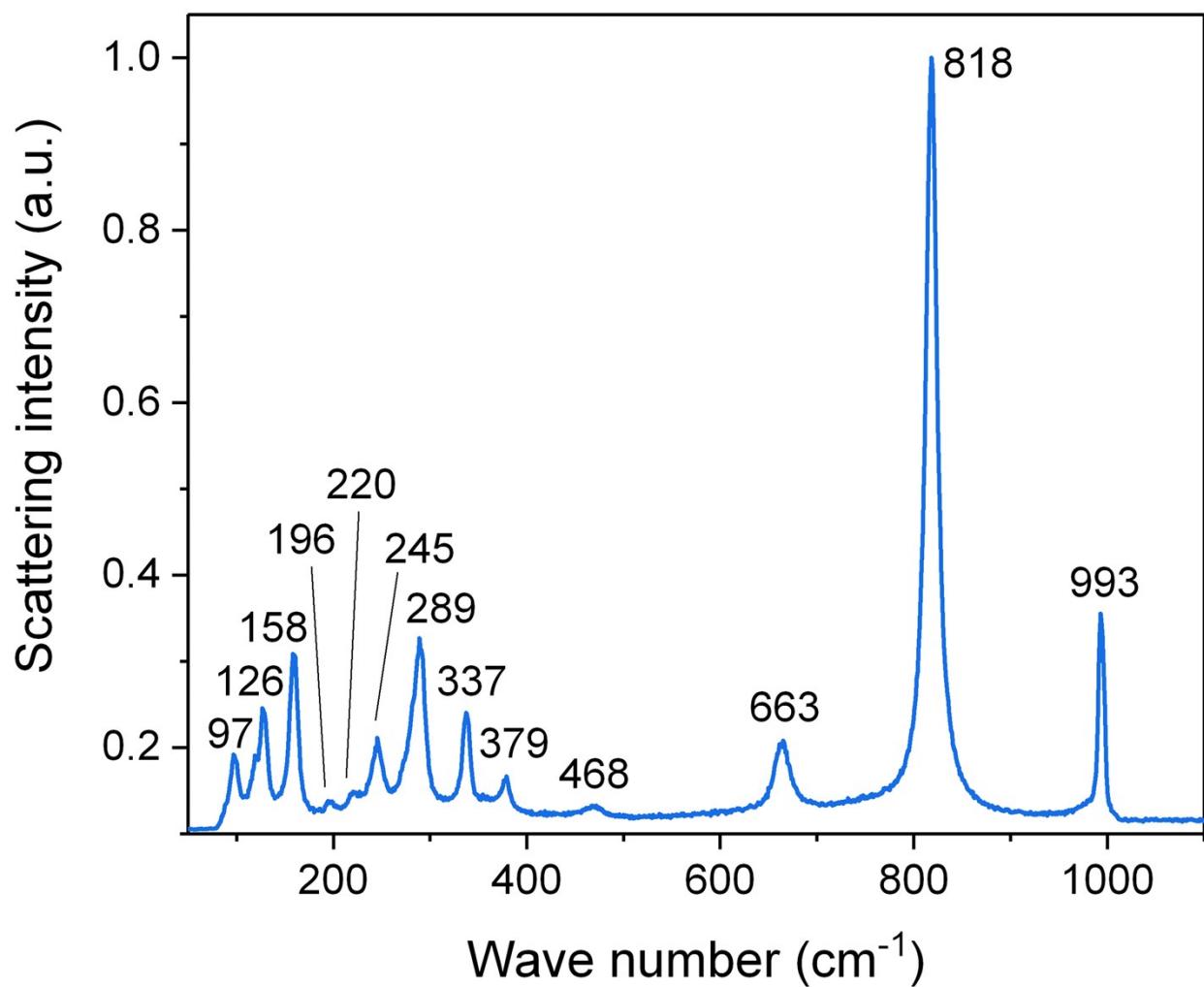
**Fig. S1.** FE-SEM micrographs of (a) 5 nm (b) 10 nm and (c) 20nm treated Cr evaporated layer.



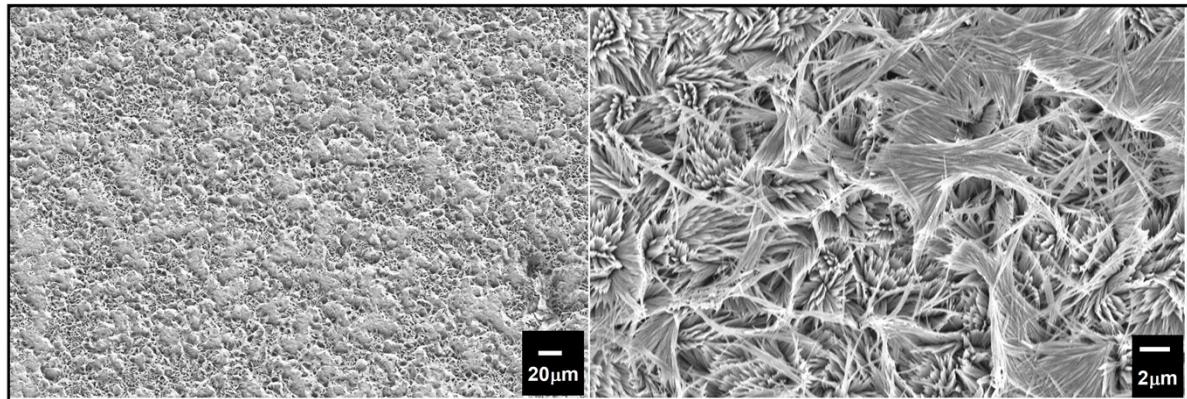
**Fig. S2.** FE-SEM micrographs of (a) 40 nm and (b) 100 nm evaporated MoO<sub>3</sub> seed layer on FTO substrates.



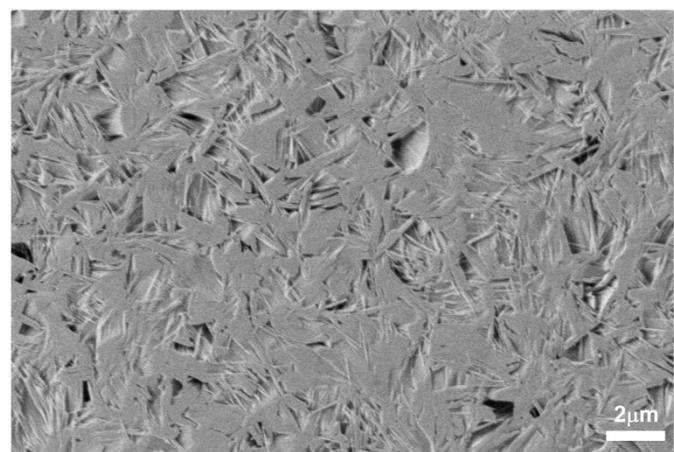
**Fig. S3.** (a) XRD patterns of seed layer and vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades on Si/SiO<sub>2</sub> substrate. FE-SEM images of (b) seed layer, (c) cross-section, (d) top view of vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades on Si/SiO<sub>2</sub> substrate and (e) EDX elemental peaks of the vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades



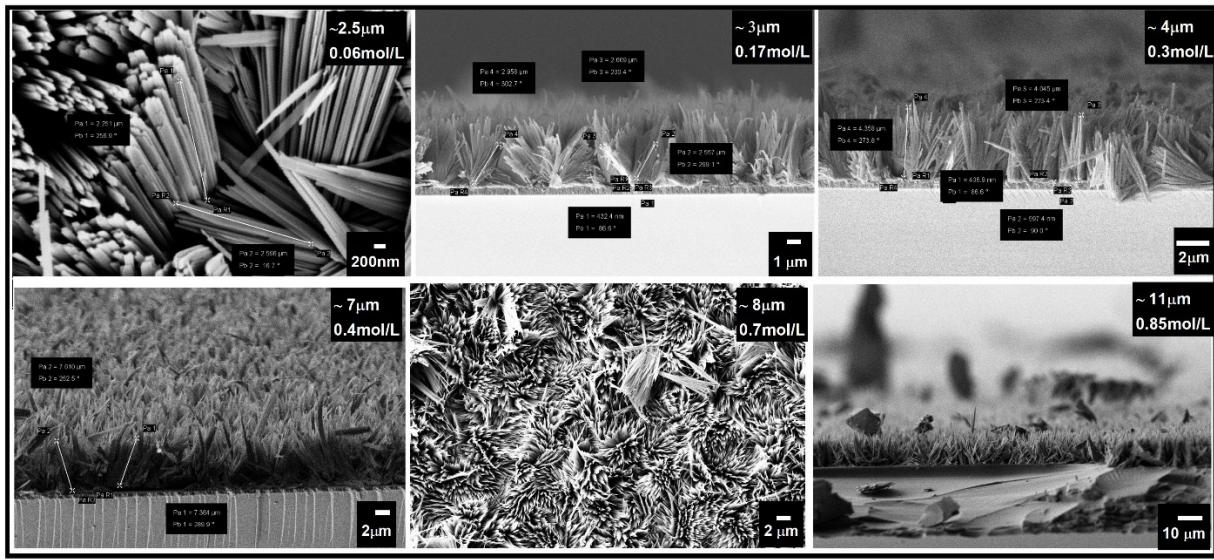
**Fig. S4.** Raman spectrum of the vertically aligned  $\alpha\text{-MoO}_3$  nanoblades recorded using a laser wavelength of 488 nm.



**Fig. S5.** FE-SEM micrographs show the overgrowth of the vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades due to an increased hydrothermal reaction time of 4h (using acid concentration of 0.3 mol/L).



**Fig. S6.** FE-SEM micrograph of backside of the vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades after removal from the substrate.



**Fig. S7.** FE-SEM micrographs show the growth of the vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblades via different acid concentrations on seed layer of 10/100 nm of Cr/MoO<sub>3</sub>.

**Table 2.** The obtained vertically aligned  $\alpha$ -MoO<sub>3</sub> nanoblade's length corresponding to the used Acid concentration.

Acid concentration (mol/L)	Vertically aligned $\alpha$ -MoO <sub>3</sub> nanoblade's length(μm)
0.06	~ 2.5
0.17	~ 3
0.3	~ 4
0.4	~ 7
0.7	~ 8
0.85	~ 11